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#4 1763  
PATENT

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Patent Application of

Jennifer Sun et al.

Application No.: 10/075,967

Filed: February 14, 2002

For: YTTRIUM OXIDE BASED SURFACE  
COATING FOR SEMICONDUCTOR  
IC PROCESSING VACUUM  
CHAMBERS

Group Art Unit: 1763

Confirmation No. 9245

Examiner: Unknow

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Washington, D.C. 20231

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